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APPLICANTS

Ji Yong Park, Suwon-city, KOREA, REPUBLIC OF;
 Hye Hyang Park, Suwon-city, KOREA, REPUBLIC OF;

** CONTINUING DATA ***** *None*

** FOREIGN APPLICATIONS ***** *Yes*
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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>Martin J. Kim</i> Examiner's Signature Initials				

ADDRESS
 21171
 STAAS & HALSEY LLP
 SUITE 700
 1201 NEW YORK AVENUE, N.W.
 WASHINGTON, DC
 20005

TITLE
 Polycrystalline silicon thin film, fabrication method thereof, and thin film transistor without directional dependency on active channels fabricated using the same

FILING FEE RECEIVED 996	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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